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Kim

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(54) **SEMICONDUCTOR PACKAGE AND METHOD FOR FABRICATING THE SAME**

(2013.01); *H01L 2224/05599* (2013.01); *H01L 2224/29099* (2013.01); *H01L 2224/32145* (2013.01); *H01L 2224/48106* (2013.01); *H01L 2224/48225* (2013.01); *H01L 2224/73265* (2013.01); *H01L 2225/0651* (2013.01); *H01L 2225/06555* (2013.01); *H01L 2924/1434* (2013.01)

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(58) **Field of Classification Search**

CPC *H01L 25/0657*; *H01L 24/32*; *H01L 24/48*; *H01L 24/73*; *H01L 2924/1434*; *H01L 2225/0651*; *H01L 2225/06555*; *H01L 2224/32145*; *H01L 2224/48225*; *H01L 2224/73265*; *H01L 2224/48106*

See application file for complete search history.

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(56) **References Cited**

(65) **Prior Publication Data**

US 2016/0064360 A1 Mar. 3, 2016

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(62) Division of application No. 14/452,305, filed on Aug. 5, 2014, now Pat. No. 9,214,452.

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KR 10-2011-0075402 A 7/2011

Primary Examiner — Roy Potter

(30) **Foreign Application Priority Data**

Apr. 18, 2014 (KR) 10-2014-0046992

(57) **ABSTRACT**

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H01L 25/065 (2006.01)
H01L 23/00 (2006.01)

(52) **U.S. Cl.**
CPC *H01L 25/0657* (2013.01); *H01L 24/32* (2013.01); *H01L 24/48* (2013.01); *H01L 24/73*

A semiconductor package includes a package substrate on which a substrate pad is disposed, a structure disposed over the package substrate, a semiconductor chip disposed over the structure using an adhesive member having a magnetic material layer disposed therein, a chip pad disposed on a top surface of the semiconductor chip, and a bonding wire coupling the substrate pad and the chip pad.

10 Claims, 16 Drawing Sheets

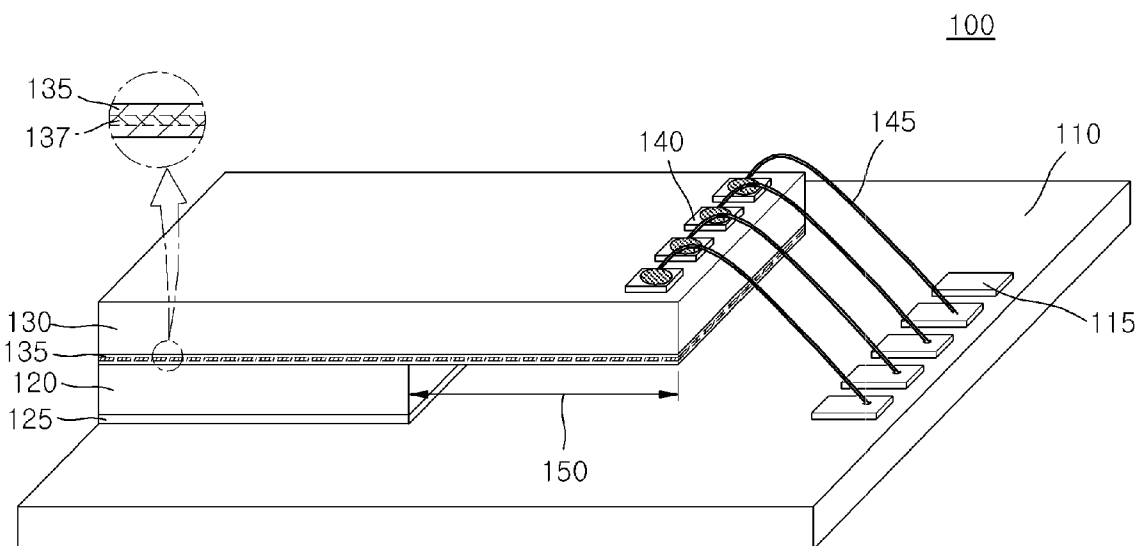


FIG. 1

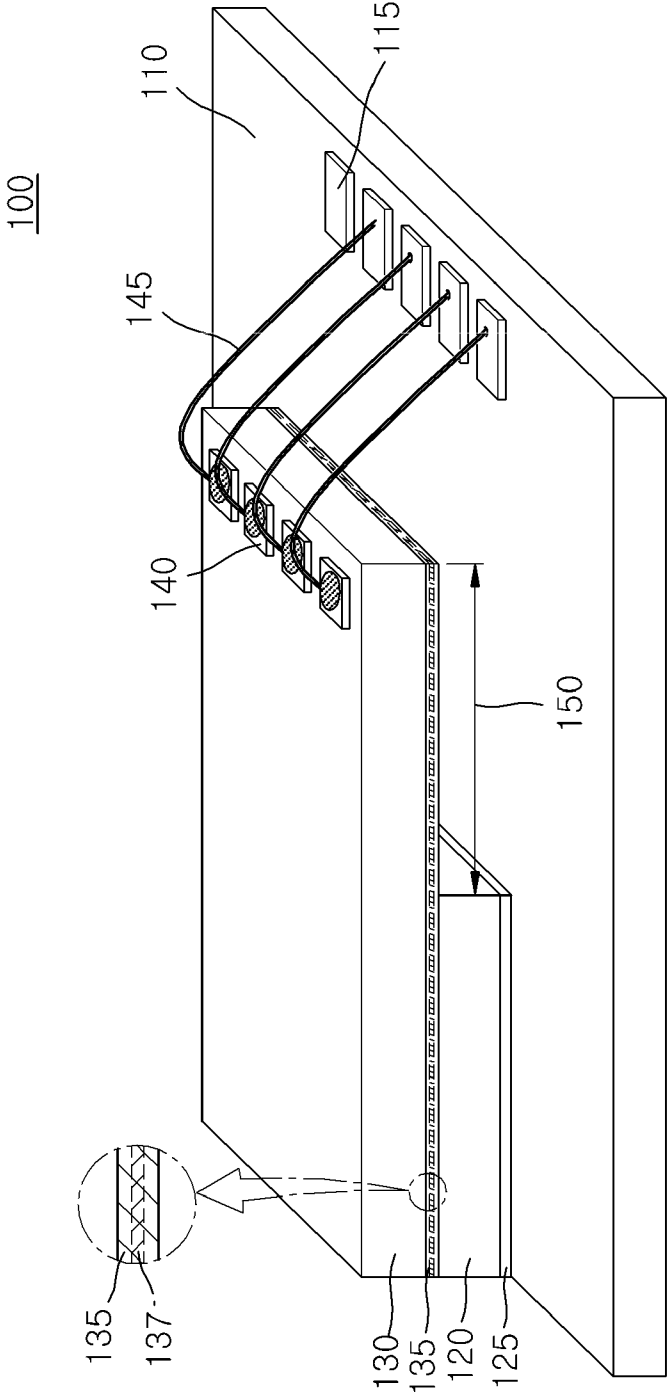


FIG. 2

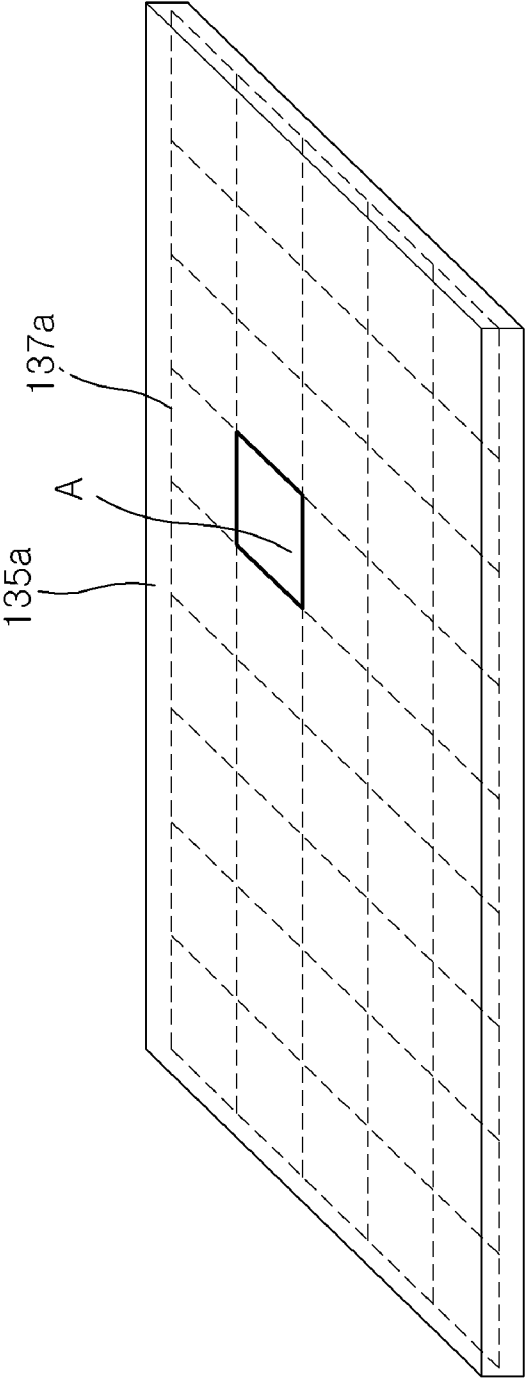


FIG. 3

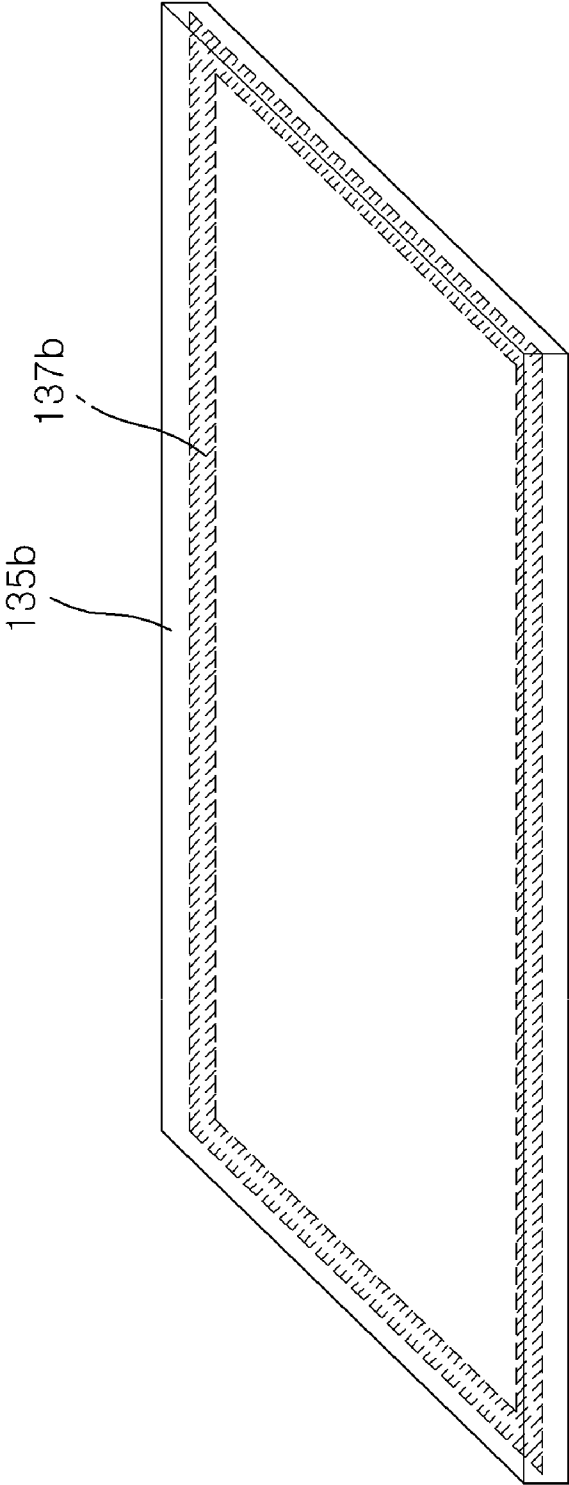


FIG. 4

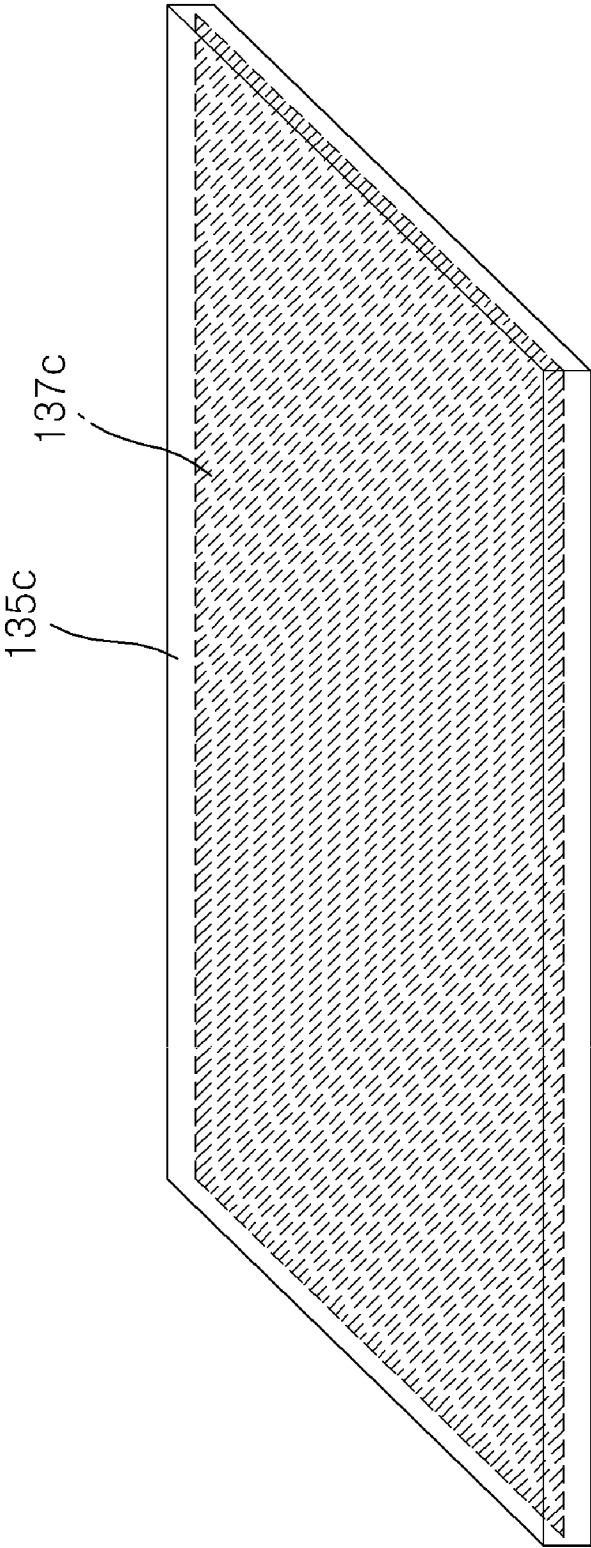


FIG. 5

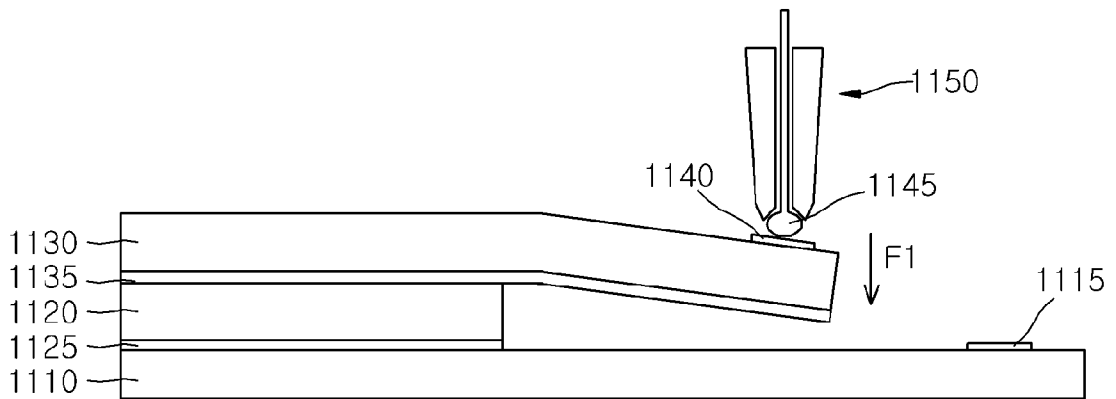


FIG. 6

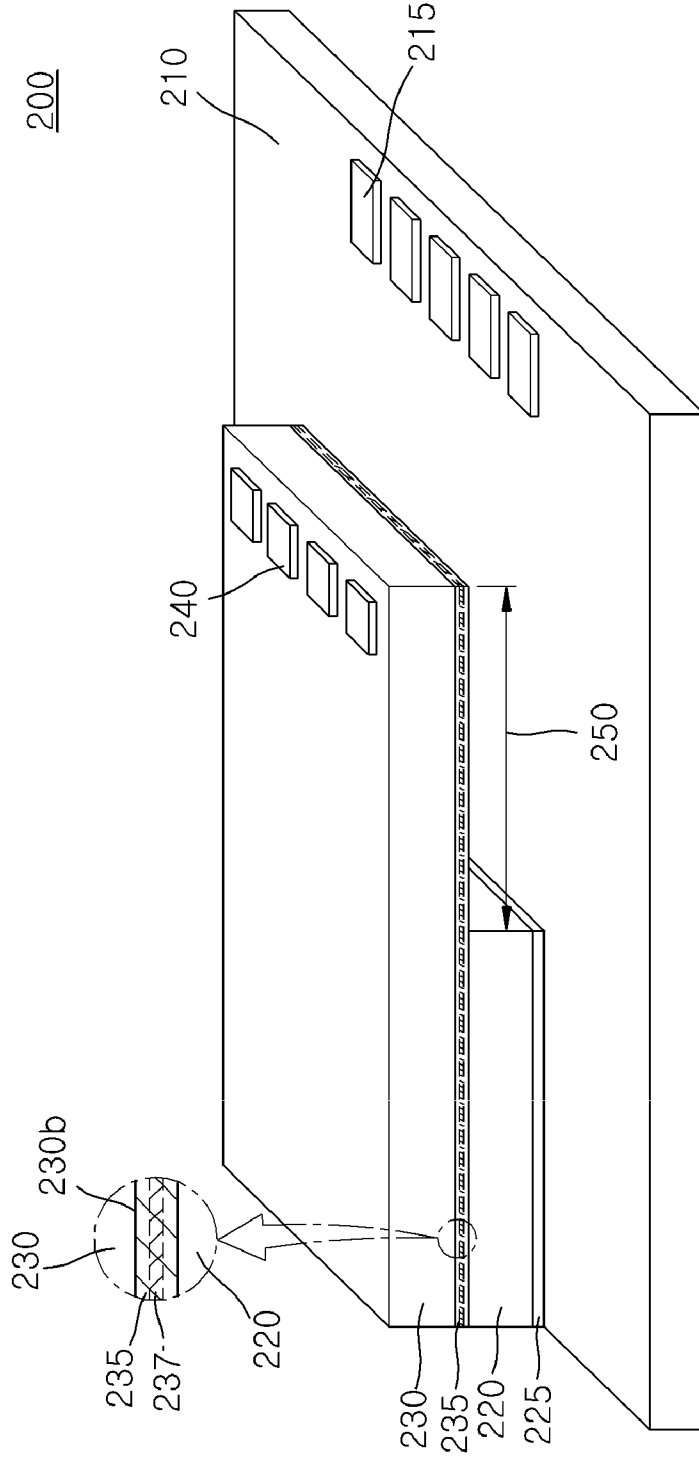


FIG. 7

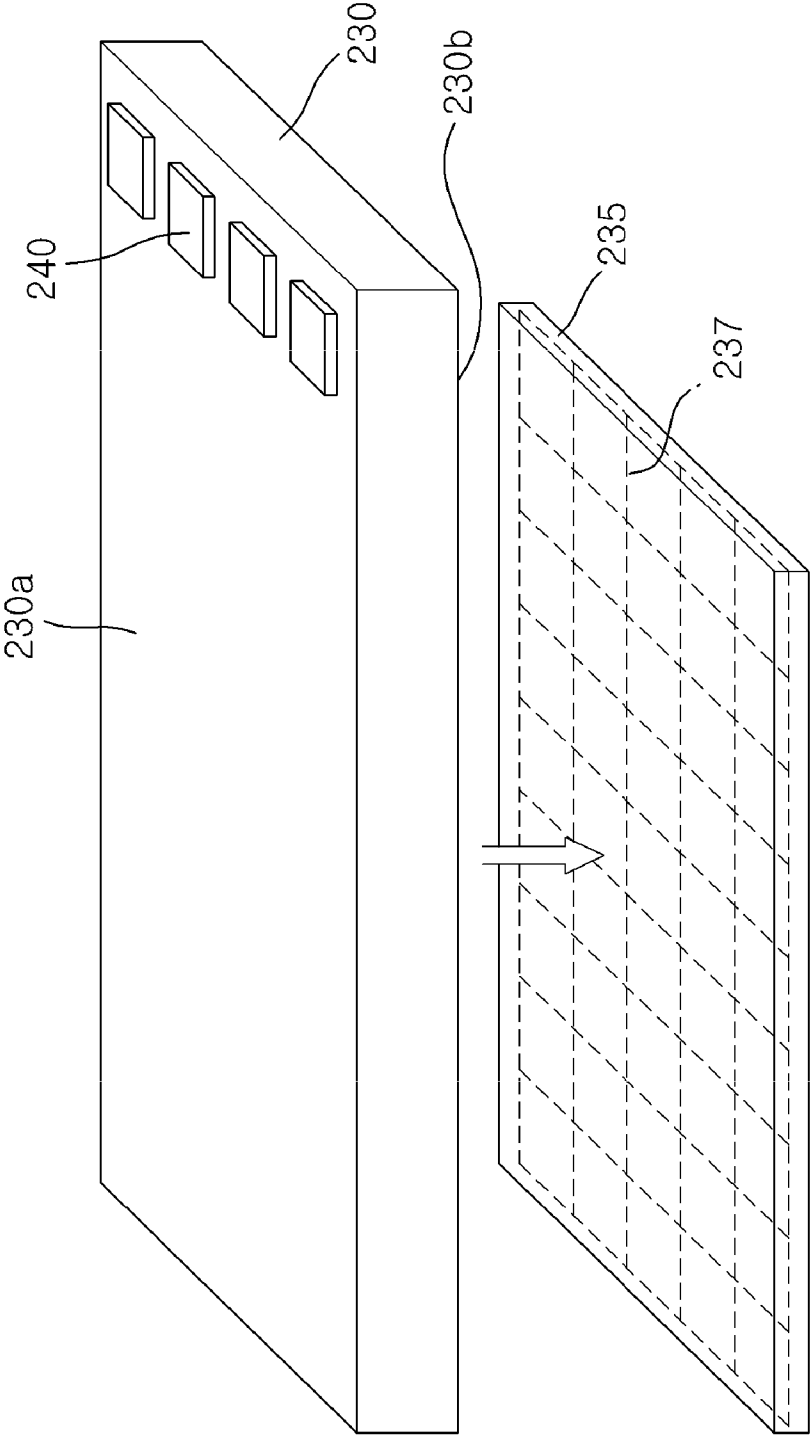


FIG. 8

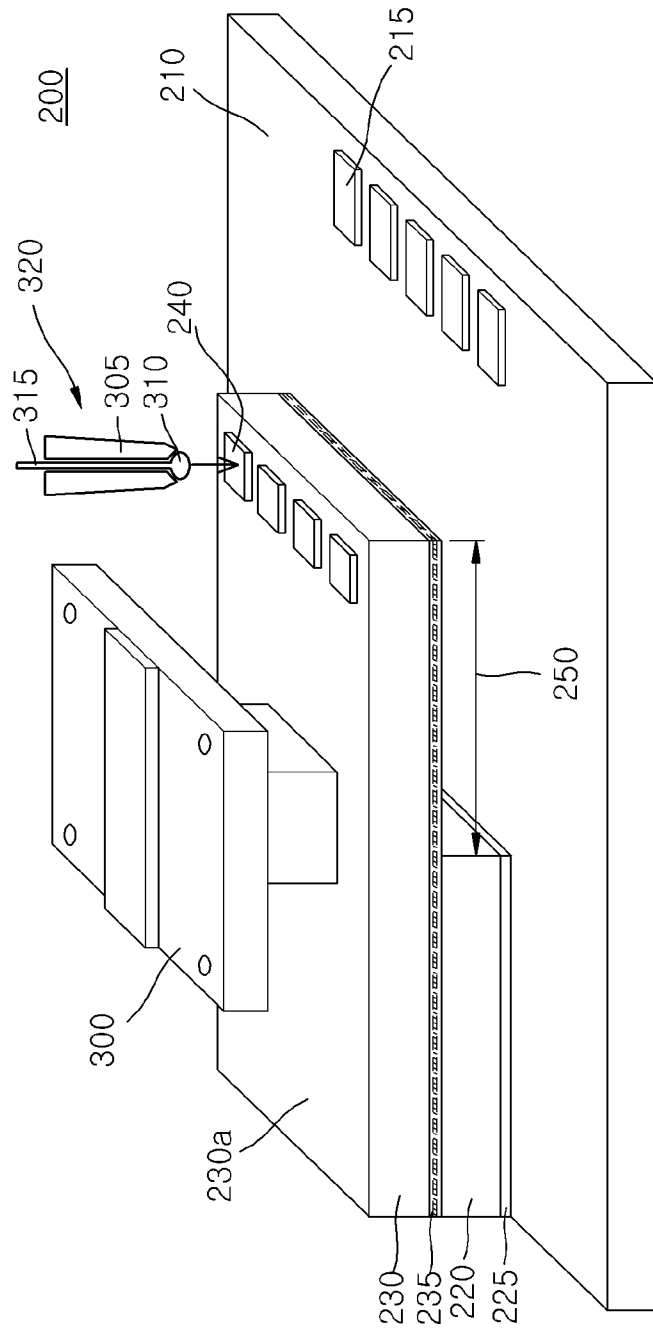


FIG. 9

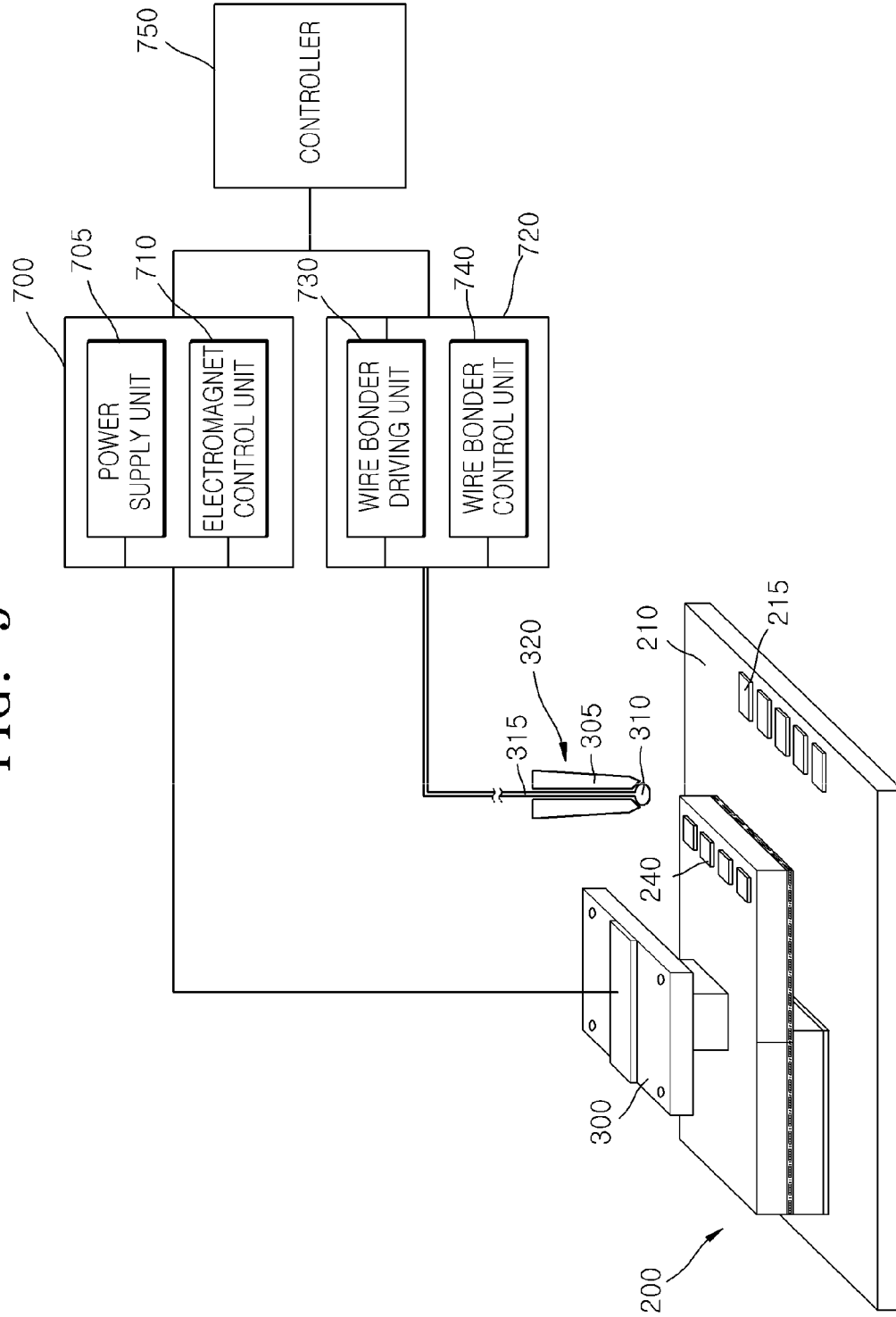


FIG. 10

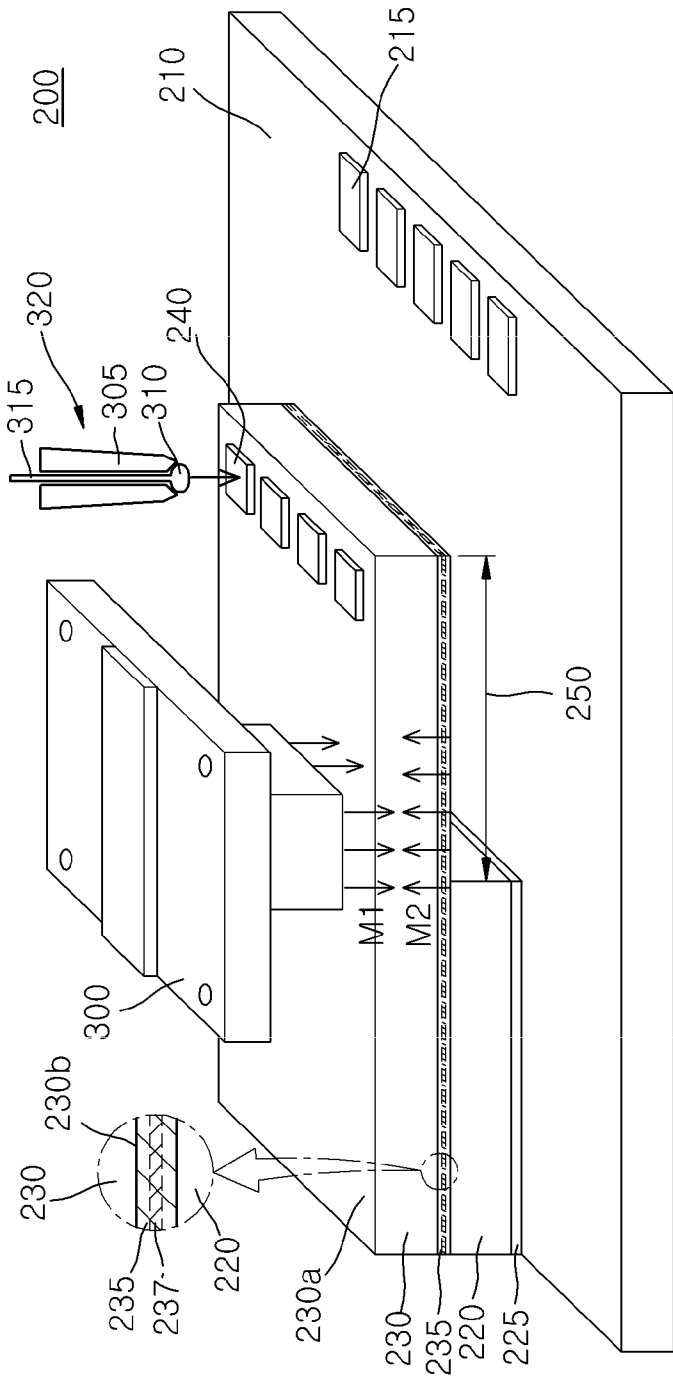


FIG. 11

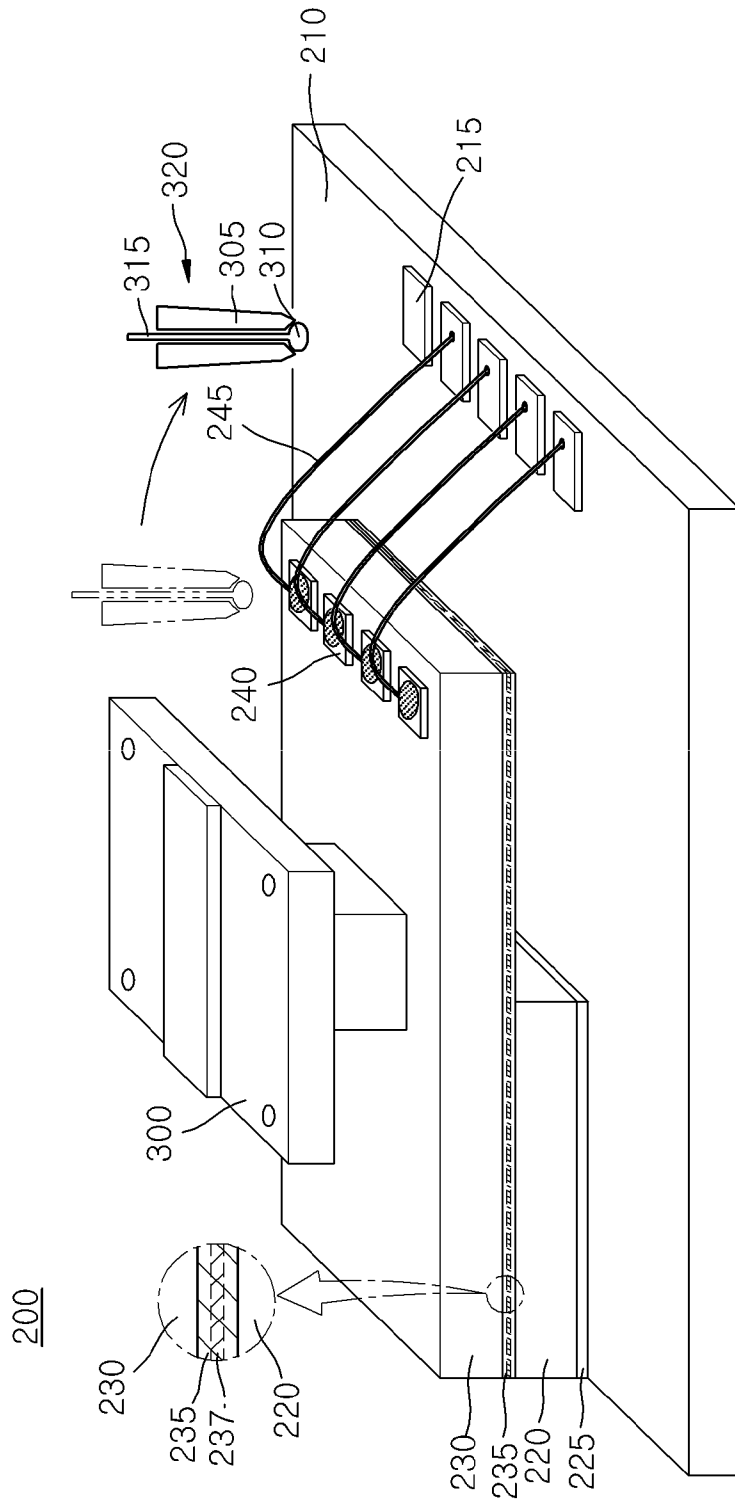


FIG. 12

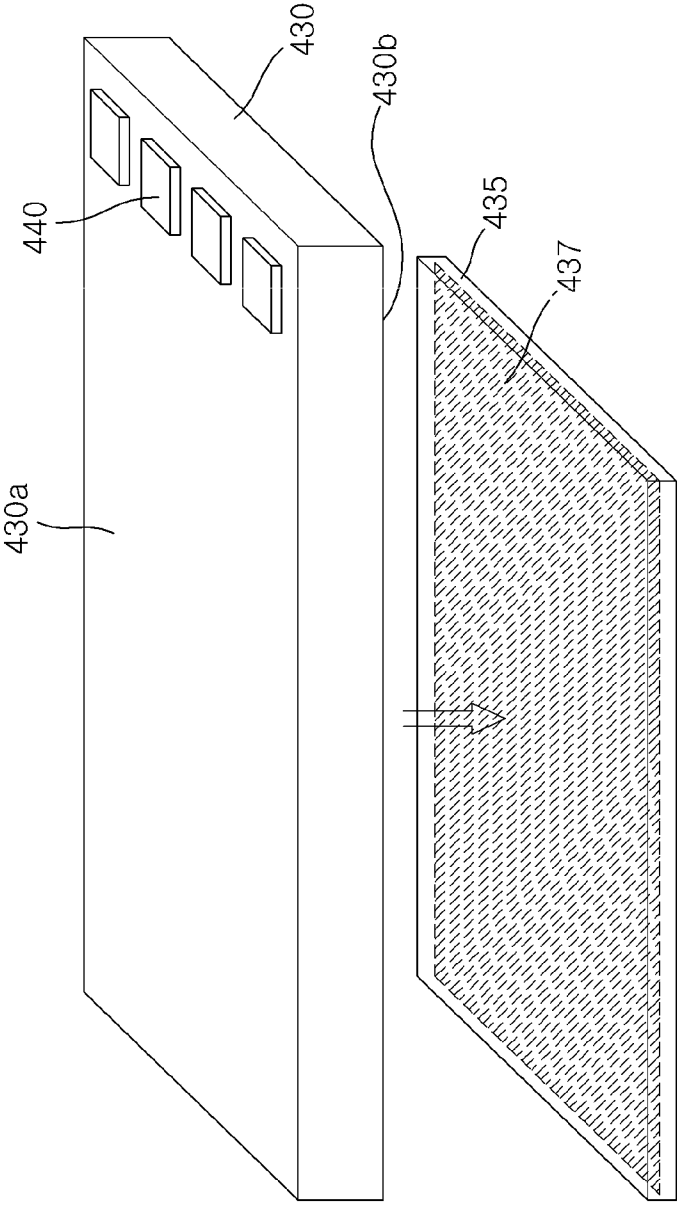


FIG. 13

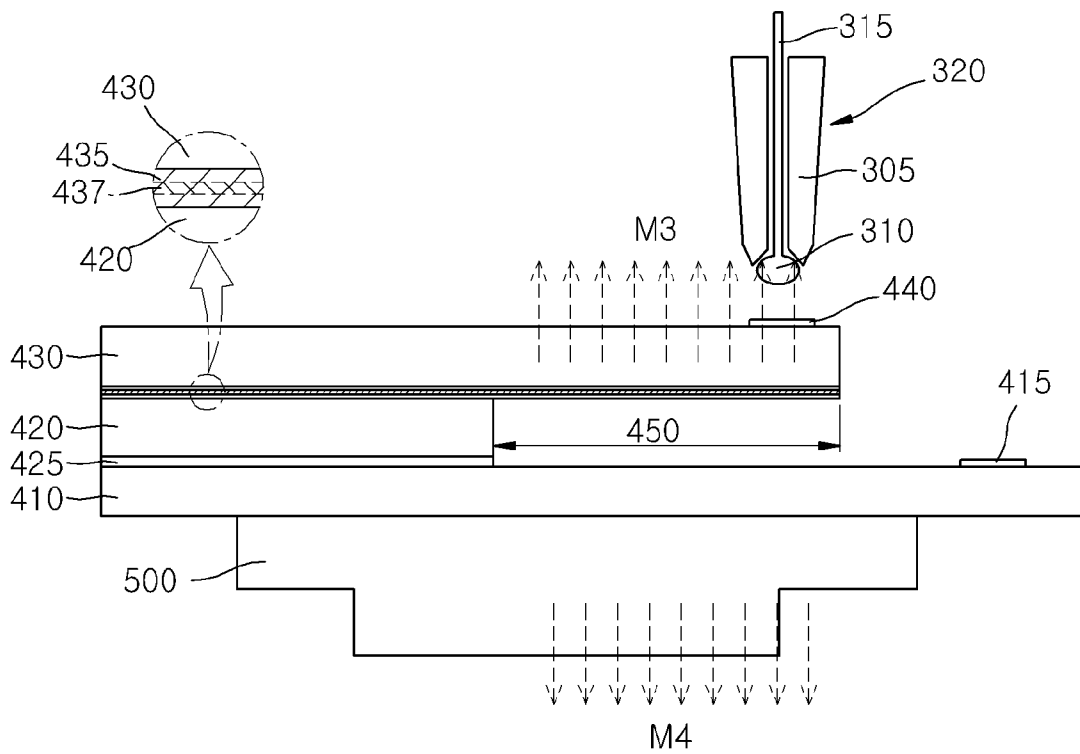


FIG. 14

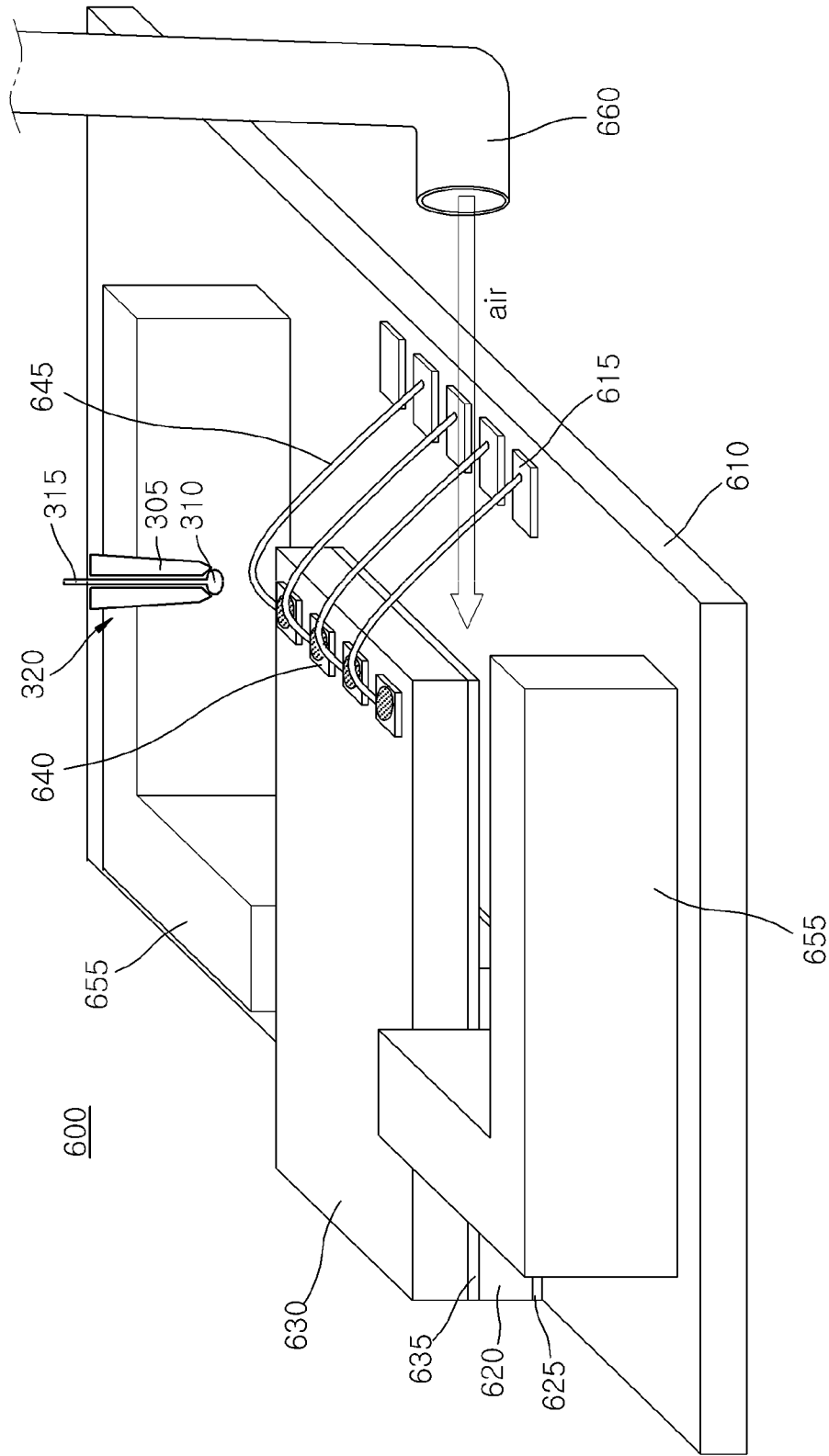


FIG. 15

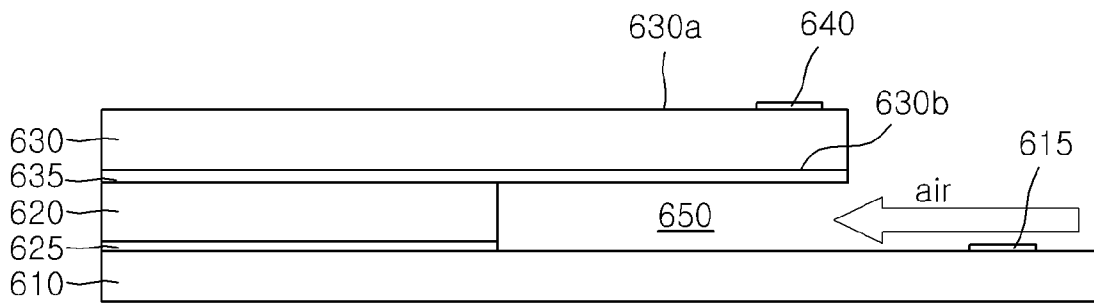


FIG. 16

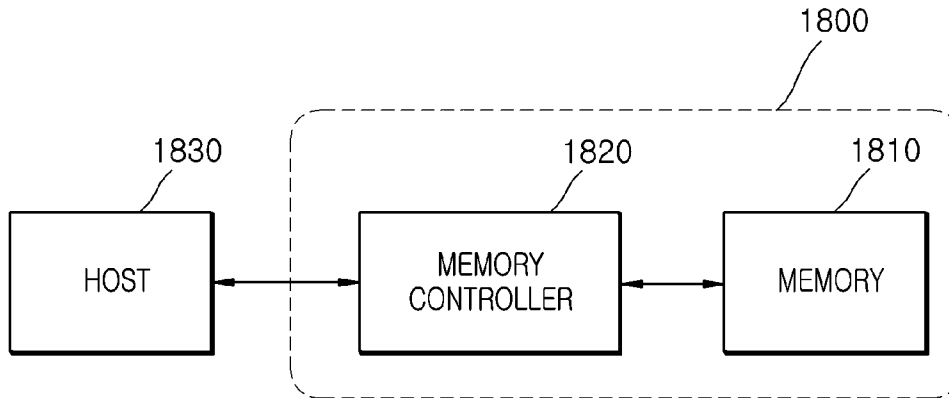
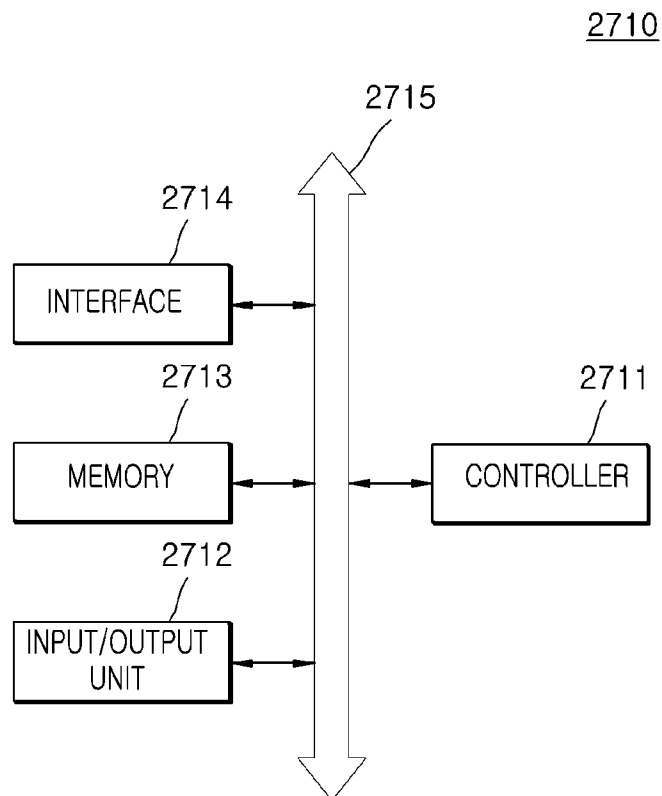


FIG. 17



SEMICONDUCTOR PACKAGE AND METHOD FOR FABRICATING THE SAME

CROSS-REFERENCES TO RELATED APPLICATIONS

The present application is a divisional of U.S. application Ser. No. 14/452,305, filed Aug. 5, 2014, which claims priority to Korean Patent Application Number 10-2014-0046992, filed on Apr. 18, 2014, which are incorporated by reference in their entirety.

BACKGROUND

Embodiments of the present disclosure relate to a semiconductor package, and more particularly, to a semiconductor package and a method for fabricating the same.

Recently, electronic devices have been reduced in size and improved in performance, and the demand for mobile products has increased. Thus, the demand for ultra-small and large-capacity semiconductor packages has also increased. Techniques for increasing a storage capacity of a semiconductor device may include increasing the integration level of a semiconductor chip and mounting a plurality of semiconductor chips in a semiconductor package. Mounting the plurality of semiconductor chips in the semiconductor package enables increasing the storage capacity of the semiconductor device by modifying a packaging process. Thus, the semiconductor industry employs a multi-chip package including a plurality of semiconductor chips to increase the storage capacity of the semiconductor device.

Techniques for forming a multi-chip package may include mounting a plurality of chips disposed in a horizontal direction and mounting a plurality of chips disposed in a vertical direction. Due to the characteristic of electronic devices which need to be reduced in size, a stack type multi-chip package including a plurality of semiconductor chips stacked in one direction packaged therein may be used. The stack type multi-chip package increases density within a limited space by stacking a plurality of semiconductor chips in a vertical direction.

SUMMARY

Various embodiments are directed to semiconductor package and methods of manufacturing the same.

In some embodiments, a semiconductor package may include: a package substrate on which a substrate pad is disposed; a structure disposed over the package substrate; a semiconductor chip attached to the structure using an adhesive member, the adhesive member has a magnetic material layer disposed therein; a chip pad disposed on a top surface of the semiconductor chip; and a bonding wire coupling the substrate pad and the chip pad.

According to further embodiments, a method for fabricating a semiconductor package may include: preparing a package substrate on which a substrate pad is disposed; disposing a lower structure over the package substrate; preparing a semiconductor chip on which a chip pad is disposed, the chip pad being disposed on top surface of an edge part of the semiconductor chip; disposing the semiconductor chip over the lower structure with an adhesive member disposed between the semiconductor chip and the lower structure such that the semiconductor chip has an overhang structure in which the edge part protrudes from a side of the lower structure, the adhesive member having a magnetic material layer disposed therein; applying a magnetic field to the magnetic

material layer so as to support the semiconductor chip; and forming a bonding wire to couple the substrate pad and the chip pad while the semiconductor chip is supported by the magnetic field.

BRIEF DESCRIPTION OF THE DRAWINGS

FIG. 1 is a perspective view of a semiconductor package in accordance with an embodiment of the present disclosure.

FIGS. 2 to 4 show a magnetic material layer disposed in an adhesive member according to an embodiment.

FIG. 5 illustrates a wire bonding process.

FIGS. 6 through 11 illustrate a process for fabricating a semiconductor package in accordance with an embodiment.

FIGS. 12 and 13 illustrate a process for fabricating a semiconductor package in accordance with another embodiment.

FIGS. 14 and 15 illustrate a process for fabricating a semiconductor package in accordance with another embodiment.

FIG. 16 is a block diagram illustrating an electronic system including a package according to an embodiment.

FIG. 17 is a block diagram illustrating another electronic system including a package according to an embodiment.

DESCRIPTION OF SPECIFIC EMBODIMENTS

Embodiments of the present disclosure will hereinafter be described in detail with reference to the accompanying drawings. It should be noted that the drawings are not to precise scale and may be exaggerated in thickness of lines or sizes of components for descriptive convenience and clarity. Furthermore, the terms as used herein are defined by taking functions of the embodiments into account and may vary according to the custom or intention of users or operators. Therefore, the terms should be interpreted according to the overall disclosures set forth herein.

FIG. 1 is a perspective view of a semiconductor package in accordance with an embodiment of the present disclosure. The semiconductor package 100 includes a package substrate 110, a plurality of substrate pads 115, first and second stacked semiconductor chips 120 and 130, first and second adhesive members 125 and 135, a plurality of chip pads 140, and a bonding wire 145.

The second adhesive member 135 is positioned between the first and second semiconductor chips 120 and 130 so as to bond the first semiconductor chip 120 to the second semiconductor chip 130. The second adhesive member 135 includes a magnetic material layer 137 disposed therein.

The package substrate 110 may include a printed circuit board (PCB) or flexible PCB, and may include semiconductor chips or integrated circuit chips mounted thereon. The package substrate 110 includes a front side and a back side facing the front side. Although not illustrated in FIG. 1, the package substrate 110 may include circuit wiring patterns arranged therein.

The plurality of substrate pads 115 is disposed on the front side of the package substrate 110 to electrically couple the first and second semiconductor chips 120 and 130 to the package substrate 110. The substrate pads 115 may transmit electrical signals to the back side of the package substrate 110 through the circuit wiring patterns arranged in the package substrate 110. The package substrate 110 may include coupling wirings (not illustrated) such as coupling vias for coupling the circuit wiring patterns.

The number of substrate pads 115 illustrated in FIG. 1 is illustrative and embodiments are not limited thereto. In another embodiment, the number of substrate pads 115 may be adjusted depending on the use of the semiconductor pack-

age. The substrate pad **115** may include a conductive material, for example, copper (Cu), nickel (Ni), gold (Au), silver (Ag), or the like.

The first and second semiconductor chips **120** and **130** may be arranged over the package substrate **110**. In an embodiment, the first and second semiconductor chips **120** and **130** may be stacked in such a manner that the first semiconductor chip **120** is attached over the package substrate **110** using the first adhesive member **125** and the second semiconductor chip **130** is attached over the first semiconductor chip **120** using the second adhesive member **135**. Although not illustrated in FIG. 1, additional semiconductor chips may be stacked over the second semiconductor chip **130**.

In the present embodiment, the structure disposed under the second semiconductor chip **130** is the first semiconductor chip **120** only, but embodiments are not limited thereto. In another embodiment, the structure disposed under the second semiconductor chip **130** may include a dummy chip or an insulating layer such as a solder resist layer. In still another embodiment, the structure disposed under the second semiconductor chip **130** may include two or more semiconductor chips. Thus, in some embodiments, two or more semiconductor chips, two or more dummy chips, or two or more insulating layers may be independently stacked, or mixed and stacked.

The first and second semiconductor chips **120** and **130** may be stacked along a first direction of the package substrate **110**. In an embodiment, the first and second semiconductor chips **120** and **130** may be arranged in such a manner that edge parts thereof deviate from each other. Thus, the edge part **150** of the second semiconductor chip **130** disposed over the first semiconductor chip **120** does not overlap with the first semiconductor chip **120**, but instead protrudes from the edge part of the first semiconductor chip **120** in a lateral direction. That is, the second semiconductor chip **130** may be stacked to have an overhang structure over the first semiconductor chip **120**.

The plurality of chip pads **140** is disposed on the second semiconductor chip **130** to couple the package substrate **110** and the second semiconductor chip **130**. The chip pads **140** arranged on the second semiconductor chip **130** may be disposed on the edge part **150** of the second semiconductor chip **130** having the overhang structure. The first and second semiconductor chips **120** and **130** may include silicon (Si). The number and arrangement of the chip pads **140** illustrated in FIG. 1 are not limited thereto. In another embodiment, the number and arrangement of the chip pads **140** may be changed according to a type of the second semiconductor chip **130**.

The bonding wire **145** couples the chip pad **140** to the substrate pad **115**. Thus, the second semiconductor chip **130** may be electrically coupled to the package substrate **110** via the chip pad **140**, the bonding wire **145**, and the substrate pad **115**. The bonding wire **145** may include a conductive metal such as copper (Cu), gold (Au), silver (Ag), or the like.

As described above, the first semiconductor chip **120** and the package substrate **110** may be attached to each other using the first adhesive member **125**, and the first semiconductor chip **120** and the second semiconductor chip **130** may be attached to each other using the second adhesive member **135**. Any of the first and second adhesive members **125** and **135** may include an adhesive tape, for example, a die attach film (DAF). The second adhesive member **135** may include the magnetic material layer **137** disposed therein.

The magnetic material layer **137** may include a magnetic material such as a ferromagnetic material, a ferrimagnetic material, graphene, or the like. The ferromagnetic material may include nickel (Ni), cobalt (Co), steel (Fe), or the like,

and the ferrimagnetic material may include magnetite, ferrite, or the like. The magnetic material layer **137** may be formed of a material which does not continuously generate a magnetic force, but instead generates a magnetic force only when exposed to a magnetic field, wherein the magnetic field may be produced when a magnetic force generator for generating a magnetic force is turned on. The second adhesive member **135** having the magnetic material layer **137** disposed therein is disposed on the back side of the second semiconductor chip **130**, including the back side of the edge part **150** of the second semiconductor chip **130** having the overhang structure.

The magnetic material layer **137** may have various shapes when disposed in the second adhesive member **135**, some of which shapes will be described with reference to FIGS. 2 to 4.

FIG. 2 shows an embodiment having a magnetic material layer **137a** disposed within an adhesive member **135a**. The magnetic material layer **137a** has a lattice pattern A in which a plurality of line-shaped patterns formed of a magnetic material are arranged to cross each other. The lattice pattern A may include one or more square, rectangle, or polygon shapes.

FIG. 3 shows an embodiment having a magnetic material layer **137b** disposed within an adhesive member **135b**. The magnetic material layer **137b** is disposed only at one or more edges of the adhesive member **135b**. The magnetic material layer **137b** may have a line-shaped border disposed near or along the edges of the adhesive member **135b**.

FIG. 4 shows an embodiment having a magnetic material layer **137c** disposed within the adhesive member **135c**. The magnetic material layer **137c** has a plate shape.

FIG. 5 illustrates a portion of a wire bonding process of bonding both ends of a bonding wire to a chip pad of a semiconductor chip and a substrate pad of a package substrate, respectively, while a capillary is moved. In FIG. 5, first and second stacked semiconductor chips **1120** and **1130** are disposed on a package substrate **1110**. A pad **1115** is disposed on the package substrate **1110**. The first semiconductor chips **1120** is attached over the package substrate **1110** using a first adhesive member **1125** and the second semiconductor chips **1130** is attached over the first semiconductor chip **1120** using a second adhesive member **1135**.

The first and second adhesive members **1125** and **1135** includes an adhesive tape, for example, a die attach film (DAF). Neither the first adhesive member **1125** nor the second adhesive member **1135** have a magnetic material layer therein.

As illustrated in FIG. 5, a wire ball **1145** is formed at an end of a capillary **1150** so as to couple a bonding wire to a chip pad **1140** disposed on the second semiconductor chip **1130**, and a force F1 is generated through the capillary **1150** and applied to press the wire ball **1145** to the chip pad **1140** in order to bond the wire ball **1145** to the chip pad **1140**.

When the force F1 is applied to the chip pad **1140** through the wire ball **1145**, the second semiconductor chip **1130** is bent toward a package substrate **1110**. When the force F1 applied to the chip pad **1140** is removed, the second semiconductor chip **1130** bent toward the package substrate **1110** tends to be restored to the original state. However, when the second semiconductor chip **1130** is bent beyond a critical value for restoration before being restored to the original state, a crack may be generated in the second semiconductor chip **1130**. Furthermore, while the second semiconductor chip **1130** is being restored, the bonding wire may be bent or cut.

On the other hand, a semiconductor package in accordance with an embodiment, such as the package **100** shown in FIG. 1, employs the second adhesive member **135** having the magnetic material layer **137** disposed therein to substantially pre-

vent the second semiconductor chip **130** from being bent during the wire bonding process. Specifically, when a magnetic force generator for generating a magnetic force is turned on, the magnetic material **137** generates a magnetic force, and the attractive force between the second adhesive member **135** having the magnetic material layer **137** disposed therein and the magnetic force generator may be used to substantially prevent the second semiconductor chip **130** from being bent beyond the critical value.

FIGS. **6** through **11** are diagrams for explaining a process for fabricating a semiconductor package in accordance with various embodiments. FIG. **9** illustrates a wire bonding apparatus in accordance with an embodiment.

Referring to FIGS. **6** and **7**, first and second semiconductor chips **220** and **230** are stacked over a package substrate **210**. In an embodiment, the package substrate **210** may include a PCB or flexible PCB. Although not illustrated in the drawings, the package substrate **210** may include circuit wiring patterns arranged therein so as to transmit electrical signals between semiconductor chips in the semiconductor package and the outside. A plurality of substrate pads **215** is formed on a top surface of the package substrate **210** so as to electrically couple the package substrate **210** to the first and second semiconductor chips **220** and **230**.

The first semiconductor chip **220** is attached over the package substrate **210** using a first adhesive member **225**, and the second semiconductor chip **230** is attached over the first semiconductor chip **220** using a second adhesive member **235** formed on a back-side surface **230b** of the second semiconductor chip **230**. The second semiconductor chip **230** has an edge part **250** that does not overlap with the first semiconductor chip **220** disposed under the second semiconductor chip **230** but instead protrudes from an edge part of the first semiconductor chip **220** in a lateral direction. That is, the second semiconductor chip **230** may be disposed over the first semiconductor chip **220** with an overhang structure.

Although not illustrated in FIG. **6**, additional semiconductor chips may be stacked over the second semiconductor chip **230**. In the present embodiment, the structure disposed under the second semiconductor chip **230** includes the first semiconductor chip **220** only, but embodiments are not limited thereto. In another embodiment, the structure disposed under the second semiconductor chip **230** may include a dummy chip or an insulating layer such as a solder resist layer. In an embodiment, the first adhesive member **225** may include an adhesive tape, such as a DAF, or an adhesive.

Referring to FIG. **7**, the second adhesive member **235** attached on the back-side surface **230b** of the second semiconductor chip **230** includes an adhesive tape, for example, a DAF. The second adhesive member **235** includes a magnetic material layer **237** disposed therein. The magnetic material layer **237** disposed in the second adhesive member **235** may include a material which reacts when a magnetic force generator for generating a magnetic force operates.

In an embodiment, the magnetic material layer **237** may include a magnetic material such as a ferromagnetic material, a ferrimagnetic material, graphene, or the like. The ferromagnetic material may include nickel (Ni), cobalt (Co), steel (Fe) or the like. The ferrimagnetic material may include magnetite, ferrite, or the like.

The magnetic material layer **237** may be formed in various patterns, such as those illustrated for magnetic material layer **137** in FIGS. **2** through **4**.

A plurality of chip pads **240** is formed on a top surface **230a** of the second semiconductor chip **230** for coupling the package substrate **210** to the second semiconductor chip **230**. The chip pads **240** disposed on the second semiconductor chip

230 may be disposed on the edge part **250** of the second semiconductor chip **230** having the overhang structure. The number of chip pads **240** illustrated in FIG. **7** is not limited thereto. In another embodiment, the number of chip pads **240** may be adjusted according to types of the first and second semiconductor chips **220** and **230**.

Referring to FIGS. **8** and **9**, a wire bonding apparatus including a magnetic force generator **300** and a wire bonder **320** is disposed at the semiconductor package **200**. The wire bonder **320** may be positioned over the semiconductor package **200**. The magnetic force generator **300** is moved to be in contact with the top surface **230a** of the second semiconductor chip **230**. The magnetic force generator **300** is positioned on the edge part **250** of the second semiconductor chip **230** having the overhang structure.

The magnetic force generator **300** may include an electromagnet (not illustrated). The electromagnet may be formed by winding a conductor around a cylindrical bobbin to form a coil. A current may be passed through the electromagnet to generate a magnetic force.

The operation of the magnetic force generator **300** may be controlled by a first controller **700** including a power supply unit **705** and an electromagnet control unit **710**. The power supply unit **705** controls a power source to pass a current to the magnetic force generator **300** or block the current. The electromagnet control unit **710** controls the current flowing through the electromagnet of the magnetic force generator **300** and thereby controls the intensity of the magnetic force.

The wire bonder **320** may include a capillary **305** having an empty space disposed therein. Through the empty space of the capillary **305**, a wire **315** may be supplied. Although not illustrated in FIG. **9**, the capillary **305** may be moved in up and down directions or left and right directions by a driving unit. The operation of the wire bonder **320** may be controlled by a second controller **720** including a wire bonder driving unit **730** and a wire bonder control unit **740**. The wire bonder driving unit **730** controls the driving unit to move the capillary **305**. The wire bonder control unit **740** generates an electrical spark at an end of the wire **315** so as to form a wire ball **310**, and supplies the wire **315**.

A controller **750** controls the first and second controllers **700** and **720** so as to control the entire wire bonding process.

Referring to FIG. **10**, the power supply unit **705** of FIG. **9** provides a current to the electromagnet within the magnetic force generator **300** to generate a first magnetic force. The first magnetic force is generated in a first direction **M1** through the interaction between the magnetic force generator **300** contacting the top surface **230a** of the edge part **250** of the second semiconductor chip **230** and the magnetic material layer **237** disposed in the second adhesive member **235**. The first direction **M1** indicates a direction in which the semiconductor package **200** including the second semiconductor chip **230** is disposed.

When the magnetic force generator **300** generates the first magnetic force in the first direction **M1**, the magnetic material layer **237** disposed in the second adhesive member **235** attached on the back-side surface **230b** of the second semiconductor chip **230** generates a second magnetic force in response. The magnetic material layer **237** generates the second magnetic force in a second direction **M2**, that is, toward the magnetic force generator **300**. Although the magnetic material layer **237** generates the second magnetic force toward the magnetic force generator **300**, because the magnetic force generator **300** contacts the edge part **250** of the second semiconductor chip **230**, the second semiconductor chip **230** is not bent upward but is instead substantially fixed in a horizontal direction during the wire bonding process.

While the second semiconductor chip **230** is supported by the second magnetic force, the capillary **305** of the wire bonder **320** is lowered until it contacts the chip pad **240**. In order to attach the wire ball **310** to the chip pad **240**, a predetermined force is applied to press the wire ball **310** to the chip pad **215** through the capillary **305**. The semiconductor package **200** in accordance with the embodiment employs the second adhesive member **235** including the magnetic material layer **237**, and thus generates an attractive force between the magnetic force generator **300** and the second adhesive member **235**. As a result, the edge part **250** of the second semiconductor chip **230** having the overhang structure may be supported and prevented from being bent substantially downward. Thus, damage such as cracks may be substantially prevented from occurring while the second semiconductor chip **230** is bent and restored.

As illustrated in FIG. **11**, the capillary **305** that contacted the chip pad **240** is subsequently lifted and moved in a transverse direction, and then lowered toward a substrate pad **215**. Initially, the capillary **305** is in contact with the chip pad **240** and is then lifted. During this process, a loop shape may be formed. As the capillary **305** is lowered and contacts the substrate pad **215**, a bonding wire **245** is formed. The capillary **305** applies a predetermined force to attach the bonding wire **245** to the substrate pad **215** so that the chip pad **240** and the substrate pad **215** are coupled to each other through the bonding wire **245**.

Subsequently, the capillary **305** is lifted and the bonding wire **245** is cut to complete the wire bonding process. When the wire bonding process is completed, the magnetic force generator **300** is separated from the top surface **230a** of the second semiconductor chip **230**.

In an embodiment, the wire bonding process is performed with the magnetic force generator **300** disposed at a predetermined height from the top surface **230a** of the second semiconductor chip **230**. When a current is supplied to the electromagnet within the magnetic force generator **300** to generate a magnetic force and the magnetic force generator **300** is separated from the second semiconductor chip **230**, the magnetic material layer **237** disposed in the second adhesive member **235** generates a magnetic force, that is, an attractive force, towards the magnetic force generator **300**. The attractive force generated may prevent substantial movement of the second semiconductor chip **230** during the wire bonding process.

FIGS. **12** and **13** are diagrams for explaining a process for fabricating a semiconductor package in accordance with another embodiment.

FIG. **13** shows first and second semiconductor chips **420** and **430** stacked over a package substrate **410**. The package substrate **410** may include a PCB or flexible PCB. A plurality of substrate pads **415** is formed on a front-side surface of the package substrate **410** so as to electrically couple the package substrate **410** to the first and second semiconductor chips **420** and **430**.

A first polarity plate **500** is disposed on a back-side surface of the package substrate **410**. The first polarity plate **500** may be defined as a plate formed of a conductor serving as an anode (+) or cathode (-).

The first semiconductor chip **420** is attached over the package substrate **410** using a first adhesive member **425**, and the second semiconductor chip **430** is attached over the first semiconductor chip **420** using a second adhesive member **435** attached on the back-side surface **430b** of the second semiconductor chip **430**. A plurality of chip pads **440** is formed on a top surface **430a** of the second semiconductor chip **430**. The chip pads **440** may be disposed on an edge part **450** of the

second semiconductor chip **430** having an overhang structure. Although not illustrated in the drawings, additional semiconductor chips may be stacked over the second semiconductor chips **430** and/or may be disposed between the first and second semiconductor chips **420** and **430**. The first adhesive member **425** may include an adhesive tape, such as, a DAF, or an adhesive.

As shown in FIG. **12**, the second adhesive member **435** attached on the back-side surface **430b** of the second semiconductor chip **430** may include an adhesive tape, for example, a DAF. The second adhesive member **435** may have a second polarity plate **437** disposed therein. The second polarity plate **437** may be defined as a plate formed of a conductor serving an anode (+) or cathode (-). The second polarity plate **437** may have the same polarity as the first polarity plate **500**. For example, when the first polarity plate **500** has a positive electric potential (+), the second polarity plate **437** may have a positive electric potential (+), and when the first polarity plate **500** has a negative (-) electric potential, the second polarity plate **437** may have a negative (-) electric potential.

When the first and second polarity plates **500** and **437** having the same polarity are positioned on the back-side surface of the package substrate **410** and in the second adhesive member **435** of the second semiconductor chip **230**, respectively, and arranged to face each other, repulsive forces **M3** and **M4** are generated between the first and second polarity plates **500** and **437**. The end part **450** of the second semiconductor chip **430** having the overhang structure is supported by the repulsive forces **M3** and **M4** generated between the first and second polarity plates **500** and **437**. Thus, when the capillary **305** of the wire bonder **320** applies a predetermined force to attach the wire ball **310** to the chip pad **440** during the wire bonding process, the second semiconductor chip **430** may be prevented from being substantially bent. When the wire bonding process is completed, the first polarity plate **500** disposed on the back-side surface of the package substrate **410** is removed.

FIGS. **14** and **15** are diagrams for explaining a process for fabricating a semiconductor package in accordance with another embodiment.

Referring to FIGS. **14** and **15**, the semiconductor package **600** includes first and second semiconductor chips **620** and **630** stacked over a package substrate **610**. A plurality of substrate pads **615** is formed on a top surface of the package substrate **610** so as to electrically couple the package substrate **610** to the first and second semiconductor chips **620** and **630**.

The first semiconductor chip **620** may be attached over the package substrate **610** using a first adhesive member **625**, and the second semiconductor chip **630** may be attached over the first semiconductor chip **620** using a second adhesive member **635** formed on a back-side surface **630b** of the second semiconductor chip **630**. A plurality of chip pads **640** is formed on a top surface **630a** of the second semiconductor chip **630**. The chip pads **640** may be disposed on an edge part of the second semiconductor chip **630** having an overhang structure. Although not illustrated in the drawings, additional semiconductor chips may be stacked over the second semiconductor chip **630** and/or may be disposed between the first and second semiconductor chips **620** and **630**. Any of the first and second adhesive members **625** and **635** may include an adhesive tape, such as a DAF, or an adhesive.

Over the package substrate **610**, air dams **655** may be disposed. The air dams **655** may be disposed over the package substrate **610** on the left and right sides of the stacked struc-

ture of the first and second semiconductor chips **620** and **640**, with the stacked structure interposed therebetween.

Then, an air injection device **660** and the capillary **305** of the wire bonder **320** are disposed over the semiconductor package **600**. Air is supplied toward the second semiconductor chip **630** from the air injection device **660**. The air supplied from the air injection device **660** is injected into a space **650** under the edge part of the second semiconductor chip **630** having the overhang structure. Then, while the air is retained in the space **650** under the edge part of the second semiconductor chip **630** by the air dams **655** disposed with the stacked structure of the first and second semiconductor chips **620** and **630** interposed therebetween, the second semiconductor chip **630** is supported by the air as if a support structure existed under the second semiconductor chip **630**.

The above-described wire bonding process using the capillary **305** is used to form a metal wire **645** for coupling a chip pad **640** to a substrate pad **615**. As the air is continuously injected into the space **650** under the edge part of the second semiconductor chip **630** having the overhang structure while the wire bonding process is performed, the second semiconductor chip **630** may be prevented from being substantially bent by the force applied by the capillary **305**.

When the wire bonding process is completed, the air injection process of the air injection device **660** is stopped. The air dams **645** may be removed after the wire bonding process.

The packages described above may be applied to various electronic systems.

Referring to FIG. **16**, the package in accordance with the embodiments may be provided in the form of a memory card **1800**. For example, the memory card **1800** may include a memory **1810** such as a nonvolatile memory device and a memory controller **1820**. The memory **1810** and the memory controller **1820** may store data or read stored data.

The memory **1810** may include at least any one among nonvolatile memory devices to which the packaging technologies of the embodiments of the present disclosure are applied. The memory controller **1820** may control the memory **1810** such that stored data is read out or data is stored in response to a read/write request from a host **1830**.

Referring to FIG. **17**, the package in accordance with an embodiment may be applied to an electronic system **2710**. The electronic system **2710** may include a controller **2711**, an input/output unit **2712**, and a memory **2713**. The controller **2711**, the input/output unit **2712**, and the memory **2713** may be coupled with one another through a bus **2715** providing a path through which data are transmitted.

For example, the controller **2711** may include at least any one of a microprocessor, a digital signal processor, a microcontroller, and logic devices capable of performing the same functions as these components. At least one of the controller **2711** and the memory **2713** may include at least any one of the packages according to the embodiments of the present disclosure. The input/output unit **2712** may include at least one selected among a keypad, a keyboard, a display device, a touch screen and so forth. The memory **2713** is a device for storing data. The memory **2713** may store data and/or commands to be executed by the controller **2711**, and the like.

The memory **2713** may include a volatile memory device such as a DRAM and/or a nonvolatile memory device such as a flash memory. For example, a flash memory may be mounted to an information processing system such as a mobile terminal or a desk top computer. The flash memory may constitute a solid state disk (SSD). In this case, the electronic system **2710** may stably store a large amount of data in a flash memory system.

The electronic system **2710** may further include an interface **2714** suitable for transmitting and receiving data to and from a communication network. The interface **2714** may be a wired or wireless type. For example, the interface **2714** may include an antenna or a wired or wireless transceiver.

The electronic system **2710** may be realized as a mobile system, a personal computer, an industrial computer, or a logic system performing various functions. For example, the mobile system may be any one of a personal digital assistant (PDA), a portable computer, a tablet computer, a mobile phone, a smart phone, a wireless phone, a laptop computer, a memory card, a digital music system, and an information transmission/reception system.

In an embodiment wherein the electronic system **2710** is an equipment capable of performing wireless communication, the electronic system **2710** may be used in a communication system such as a system employing one or more of CDMA (code division multiple access), GSM (global system for mobile communications), NADC (North American digital cellular), E-TDMA (enhanced-time division multiple access), WCDMA (wideband code division multiple access), CDMA2000, LTE (long term evolution), and Wibro (wireless broadband Internet).

Although preferred embodiments of the present disclosure have been disclosed for illustrative purposes, those skilled in the art will appreciate that various modifications, additions, and substitutions are possible, without departing from the scope and spirit of the present disclosure as defined in the accompanying claims.

What is claimed is:

1. A semiconductor package comprising:

- a package substrate on which a substrate pad is disposed;
- a structure disposed over the package substrate;
- a semiconductor chip attached to the structure using an adhesive member, the adhesive member having a magnetic material layer disposed therein;
- a chip pad disposed on a top surface of the semiconductor chip; and
- a bonding wire coupling the substrate pad and the chip pad.

2. The semiconductor package of claim **1**, wherein the semiconductor chip has an overhang structure in which an edge part of the semiconductor chip protrudes away from a side of the structure, and the chip pad is disposed on the protruding edge part of the semiconductor chip.

3. The semiconductor package of claim **2**, wherein the adhesive member is disposed on a back-side surface of the semiconductor chip, the back-side surface being opposite the top surface of the semiconductor chip.

4. The semiconductor package of claim **1**, wherein the structure comprises another semiconductor chip.

5. The semiconductor package of claim **1**, wherein the magnetic material layer comprises one or more of a ferromagnetic material, a ferrimagnetic material, and graphene.

6. The semiconductor package of claim **1**, wherein the adhesive member includes an adhesive tape.

7. The semiconductor package of claim **1**, wherein the magnetic material layer includes a lattice pattern in which a plurality of line-shaped patterns are arranged to cross each other.

8. The semiconductor package of claim **1**, wherein the magnetic material layer includes a line-shaped border disposed near a plurality of edges of the adhesive member.

9. The semiconductor package of claim **1**, wherein the magnetic material layer includes a structure having a plate shape.

10. The semiconductor package of claim 1, wherein the semiconductor package is included in an electronic system, the electronic system further comprising;
a memory; and
a controller coupled to the memory through a bus, 5
wherein the memory or the controller includes the package.

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